

L Number	Hits	Search Text	DB	Time stamp
-	1	"6297658"	USPAT; US-PGPUB	2003/03/25 12:05
-	0	6297658.URPN.	USPAT	2003/03/25 10:33
-	2	("5430816"   "5945834").PN.	USPAT	2003/03/25 10:33
-	20	5945834.URPN.	USPAT	2003/03/25 10:33
-	2	("5430816"   "5945834").PN.	USPAT	2003/03/25 10:43
-	1	"20020105354"	USPAT; US-PGPUB	2003/03/25 10:51
-	25	((("5829126") or ("5665610") or ("4614586") or ("5214296") or ("6297658") or ("5983331") or ("5315543") or ("5300814") or ("5355081") or ("5006717") or ("6518779") or ("5399890") or ("5217914") or ("5241201") or ("5825193") or ("6229329") or ("5605844") or ("5248936") or ("5892368") or ("6215321") or ("5432224") or ("6323663") or ("6005401") or ("5945834") or ("6400175")).PN.	USPAT; US-PGPUB	2003/03/25 12:08

L Number	Hits	Search Text	DB	Time stamp
-	1	6005401.pn.	USPAT	2000/10/23 11:34
-	1	5945834.pn.	USPAT	2000/10/30 12:05
-	1164	324/754.cccls.	USPAT	2000/10/20 17:48
-	50	324/754.cccls. and holes near2 probe	USPAT	2000/10/20 17:58
-	33	324/754.cccls. and holes near2 probe and pressure	USPAT	2000/10/20 17:58
-	0	hole near2 elastic adj probe	USPAT	2000/10/23 10:53
-	5087	holes near3 pressure	USPAT	2000/10/23 11:36
-	933	(324/765).CCLS.	USPAT	2000/10/23 11:36
-	2	(holes near3 pressure) and ("324/765").CCLS.)	USPAT	2000/10/23 11:37
-	10	(holes near3 pressure) and ("324/754").CCLS.)	USPAT	2000/10/23 12:21
-	1066	nakata.in.	USPAT	2000/10/23 12:24
-	3	nakata.in. and ("324/754").CCLS.)	USPAT	2000/10/23 12:21
-	3	nakata.in. and ("324/765").CCLS.)	USPAT	2000/10/23 12:22
-	2	nakata.in. and connection adj holes	USPAT	2000/10/23 12:26
-	458	nakata.in. and pressure	USPAT	2000/10/23 12:27
-	15136	matsushita.as.	USPAT	2000/10/26 16:28
-	17	matsushita.as. and pressure near2 holes	USPAT	2000/10/23 12:47
-	35	holes near2 equalize near2 pressure	USPAT	2000/10/23 12:48
-	1467	elastic near3 hole	USPAT	2000/10/23 16:57
-	18	elastic near3 hole and wafer	USPAT	2000/10/23 16:37
-	30	elastic near3 hole and probe	USPAT	2000/10/23 16:57
-	7	laser adj hole same wafer	USPAT	2000/10/26 14:12
-	4	laser adj hole same flexible	USPAT	2000/10/26 14:21
-	463	elastic adj cover	USPAT	2000/10/26 14:26
-	17	elastic adj cover and computer	USPAT	2000/10/26 14:26
-	3	elastic adj cover and calculator	USPAT	2000/10/26 14:37
-	12	elastic adj cover and semiconductor	USPAT	2000/10/26 14:39
-	10	semiconductor near3 exposing near5 laser adj beam	USPAT	2000/10/26 15:03
-	2	08/358609	USPAT	2000/10/26 15:14
-	1	("4833402").PN.	USPAT	2000/10/26 15:28
-	1	("5148103").PN.	USPAT	2000/10/26 15:15
-	1	("5219765").PN.	USPAT	2000/10/26 15:15
-	1	("5317255").PN.	USPAT	2000/10/26 15:15
-	1	("5500604").PN.	USPAT	2000/10/26 15:29
-	1	("5461326").PN.	USPAT	2000/10/26 15:30
-	1	("5225037").PN.	USPAT	2000/10/26 15:34
-	1	("5012187").PN.	USPAT	2000/10/26 15:45
-	1	("4980637").PN.	USPAT	2000/10/26 15:39
-	1	"4636722".PN.	USPAT	2000/10/26 15:40
-	1	"4758785".PN.	USPAT	2000/10/26 15:40
-	1169	(324/754).CCLS.	USPAT	2000/10/26 15:48
-	127	((("324/754").CCLS.) and laser	USPAT	2000/10/26 15:48
-	33	((("324/754").CCLS.) and laser and mask	USPAT	2000/10/26 16:14
-	0	samuel adj jacobs.in.	USPAT	2000/10/26 16:20
-	7911	samuel.in.	USPAT	2000/10/26 16:20
-	31	matsushita.as. and laser near3 hole	USPAT	2000/10/26 17:24
-	0	matsushita.as. and flexible adj probe	USPAT	2000/10/26 16:40
-	7	matsushita.as. and flexible adj substrate and bumps	USPAT	2000/10/26 17:23
-	0	(matsushita.as. and laser near3 hole) and (matsushita.as. and flexible adj substrate and bumps)	USPAT	2000/10/26 17:24
-	2	matsushita.as. and laser near3 hole and bumps	USPAT	2000/10/26 17:26
-	12	matsushita.as. and laser near3 beam and bumps	USPAT	2000/10/26 17:26
-	1159	matsushita.as. and laser near3 beam	USPAT	2000/10/26 17:27
-	3	matsushita.as. and laser near3 beam and mask near2 apertures	USPAT	2000/10/26 17:35
-	35	matsushita.as. and mask near2 apertures	USPAT	2000/10/26 17:35
-	8	"5430816"	USPAT	2000/10/30 12:06
-	1	("5430816").PN.	USPAT	2000/10/30 12:06